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Docket No.: 050389-0052

PATENT**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of : Customer Number: 20277
Chihiro KAWAI, et al. : Confirmation Number: 3373
Application No.: 10/500,975 : Group Art Unit: 2811
Filed: July 08, 2004 : Examiner: Andrew O. Arena
For: POROUS SEMICONDUCTOR AND METHOD FOR MANUFACTURING SAME

PETITION FOR EXTENSION OF TIME

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Commissioner for Patents
P.O. Box 1450
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Sir:

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I hereby certify that this paper is being facsimile transmitted to the Patent and Trademark Office on the date shown below.

Tomoki Tanida
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Tomoki Tanida 8/1/08
Signature Date

It is respectfully requested that the time for response to the Office Action dated April 1, 2008, now due to expire July 1, 2008, be extended for one month(s) and set to expire on August 1, 2008.

Please charge the extension fee of \$120.00 to Deposit Account No. 500417. Please charge any additional fees or credit any overpayment to Deposit Account No. 500417.

Respectfully submitted,

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